

Notice of References Cited			Application No. 09/336,126		Applicant(s) Ren et al.	
			Examiner Mike Migglins		Group Art Unit 1772	Page 1 of 1

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* A copy of this reference is not being furnished with this Office action.
(See Manual of Patent Examining Procedure, Section 707.05(a).)

Michael C. Liggins 9/17/04